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	APPLICANT	
	Hitoshi FUKUSHIMA	
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	December 4, 2001	2812

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.						

FOREIGN PATENT DOCUMENTS							
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation *	
						Yes	No
1.		10-217457A	08/18/1998	Japan			X
2.		99/038695	08/05/1999	WO			X
3.		11-15000	01/22/1999	Japan			X
4.		8-88402	04/02/1996	Japan			X

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.		H. Fukushima and 2 others, "Microstructure, Wettability, and Thermal Stability of Semifluorinated Self-Assembled Monolayers (SAMs) on Gold" J. Phys. Chem. B 2000, 104, pp. 7417-7423
2.		Notification of Reasons of Rejection dated June 8, 2005 in corresponding Japanese application No. JP2001-370544.

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